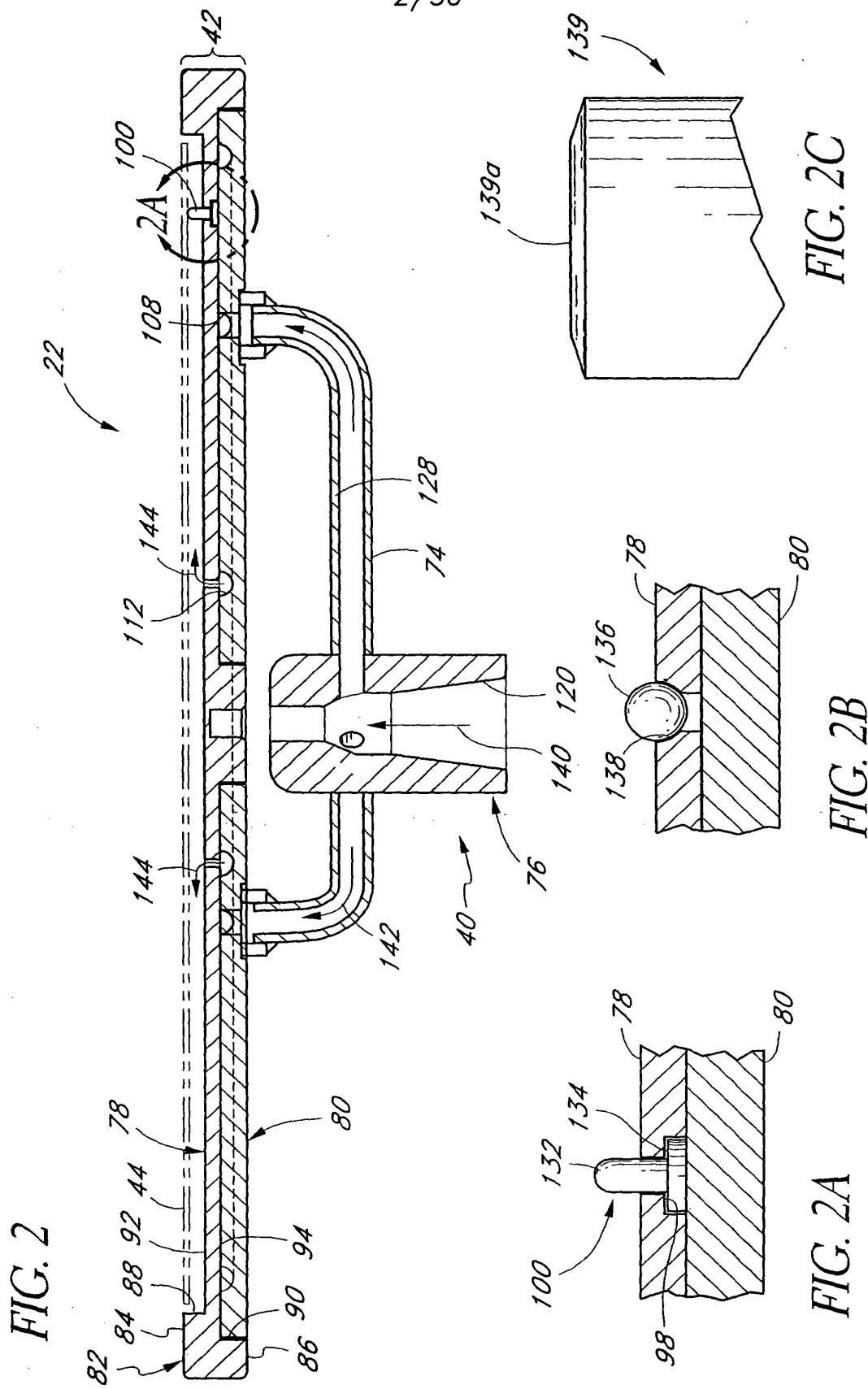


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WAFER SUPPORT SYSTEM

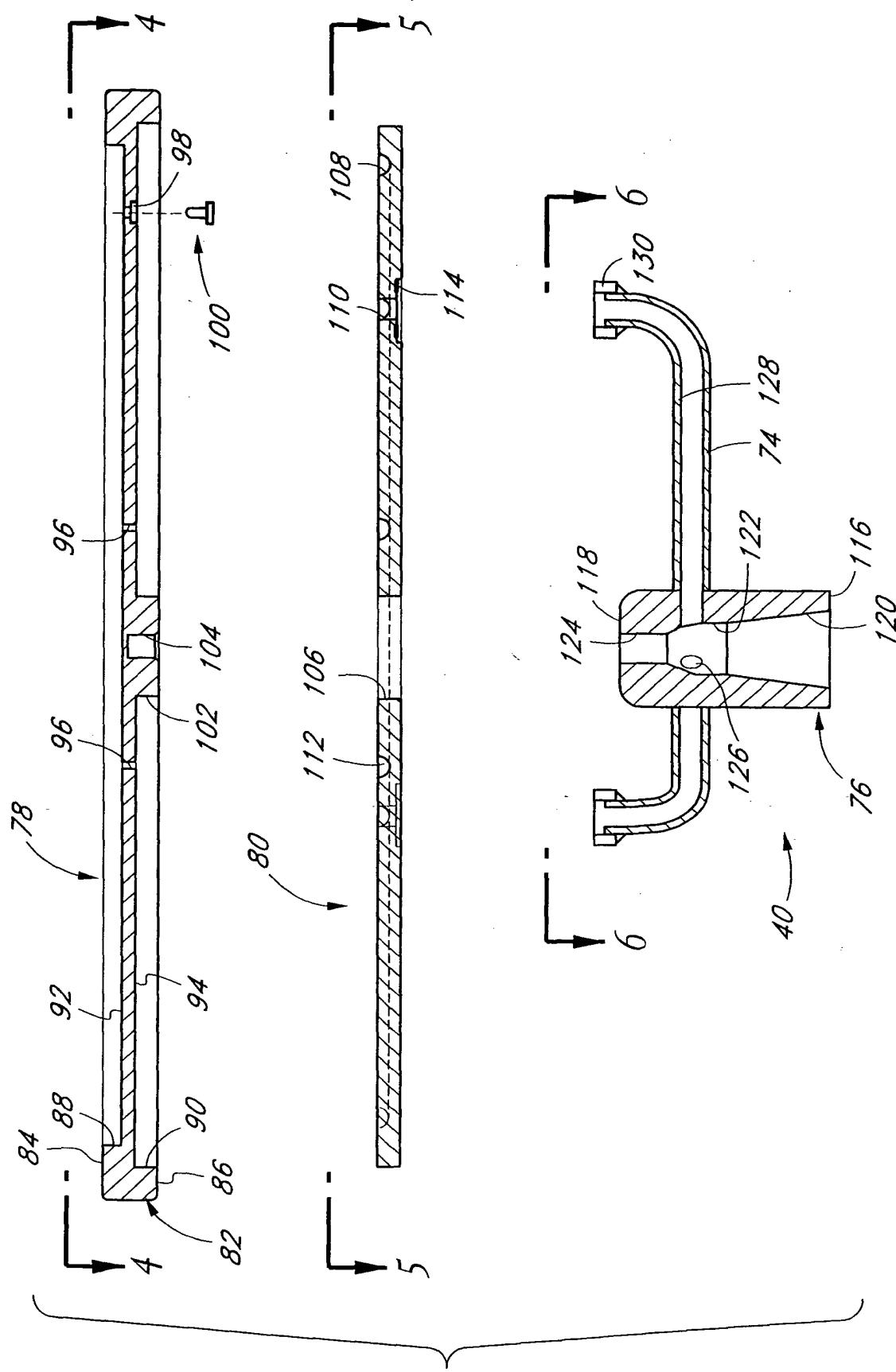
Halpin et al.

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Atty Docket: ASMEX.72CP2D3CD

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FIG. 3



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FIG. 5

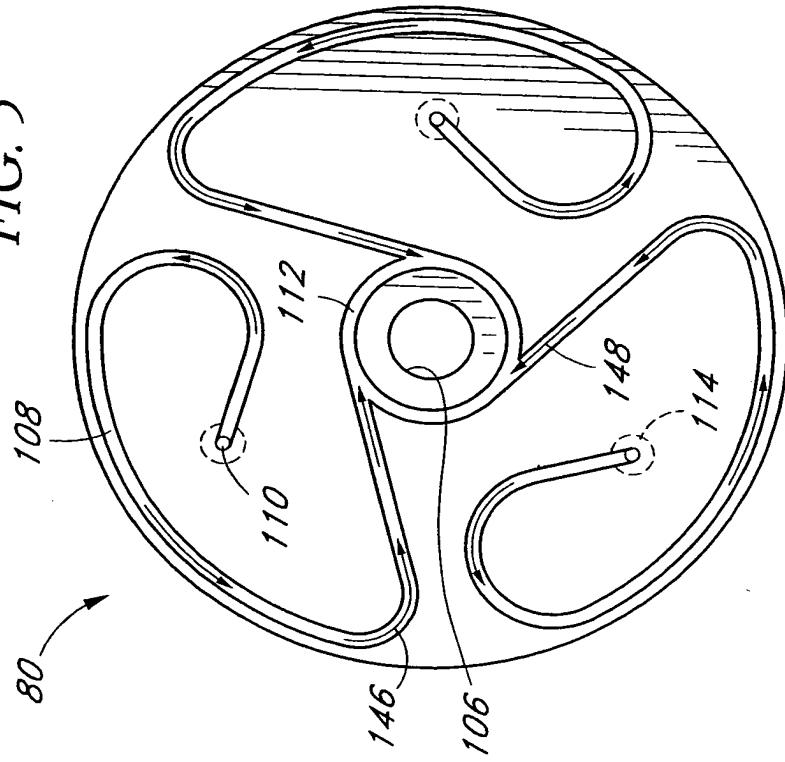
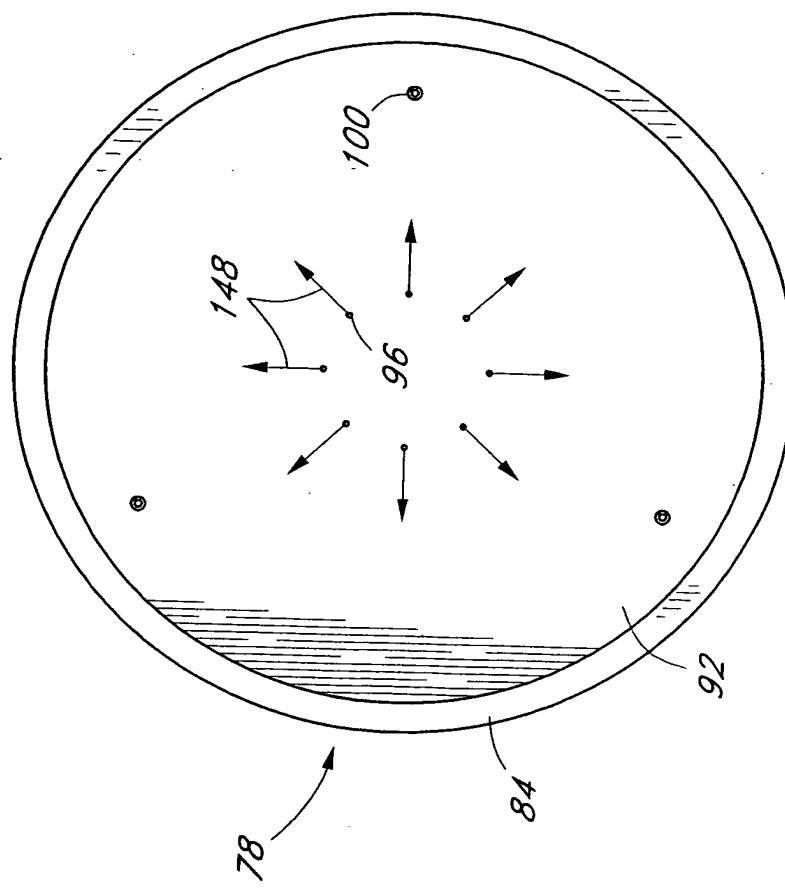


FIG. 4



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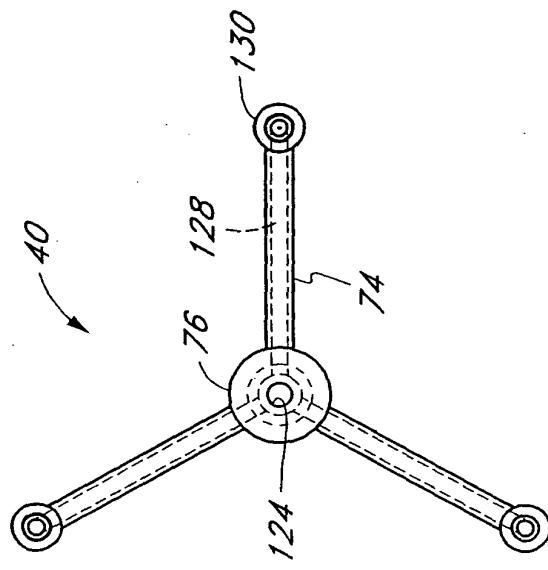


FIG. 6

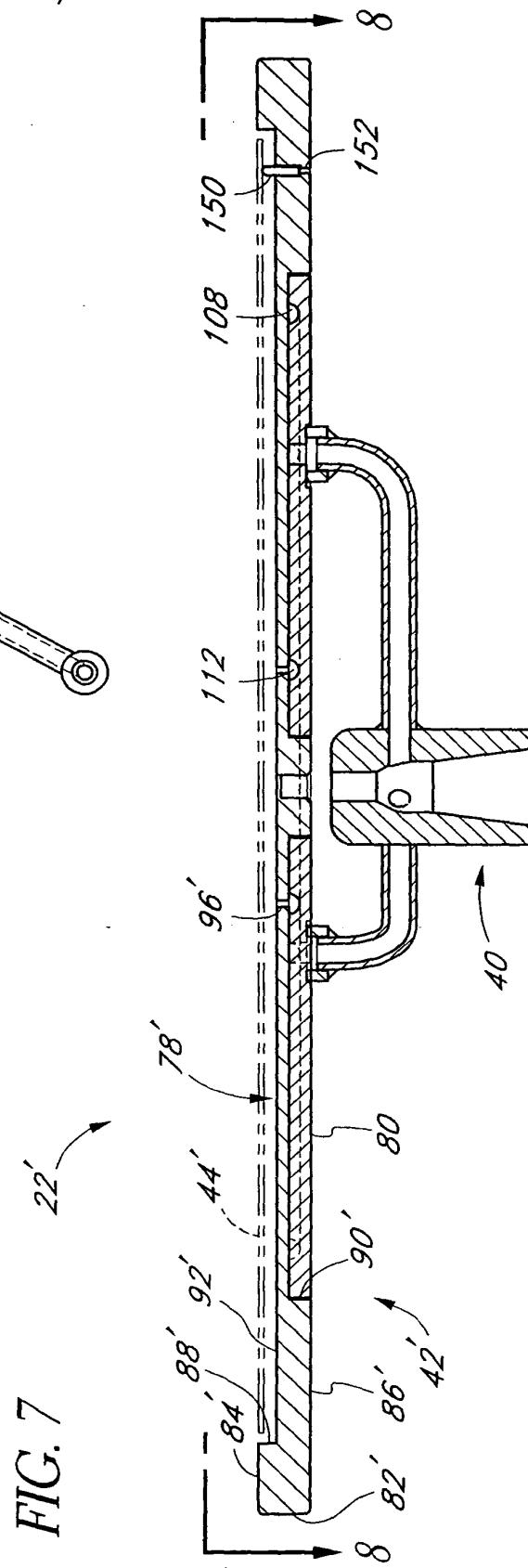


FIG. 7

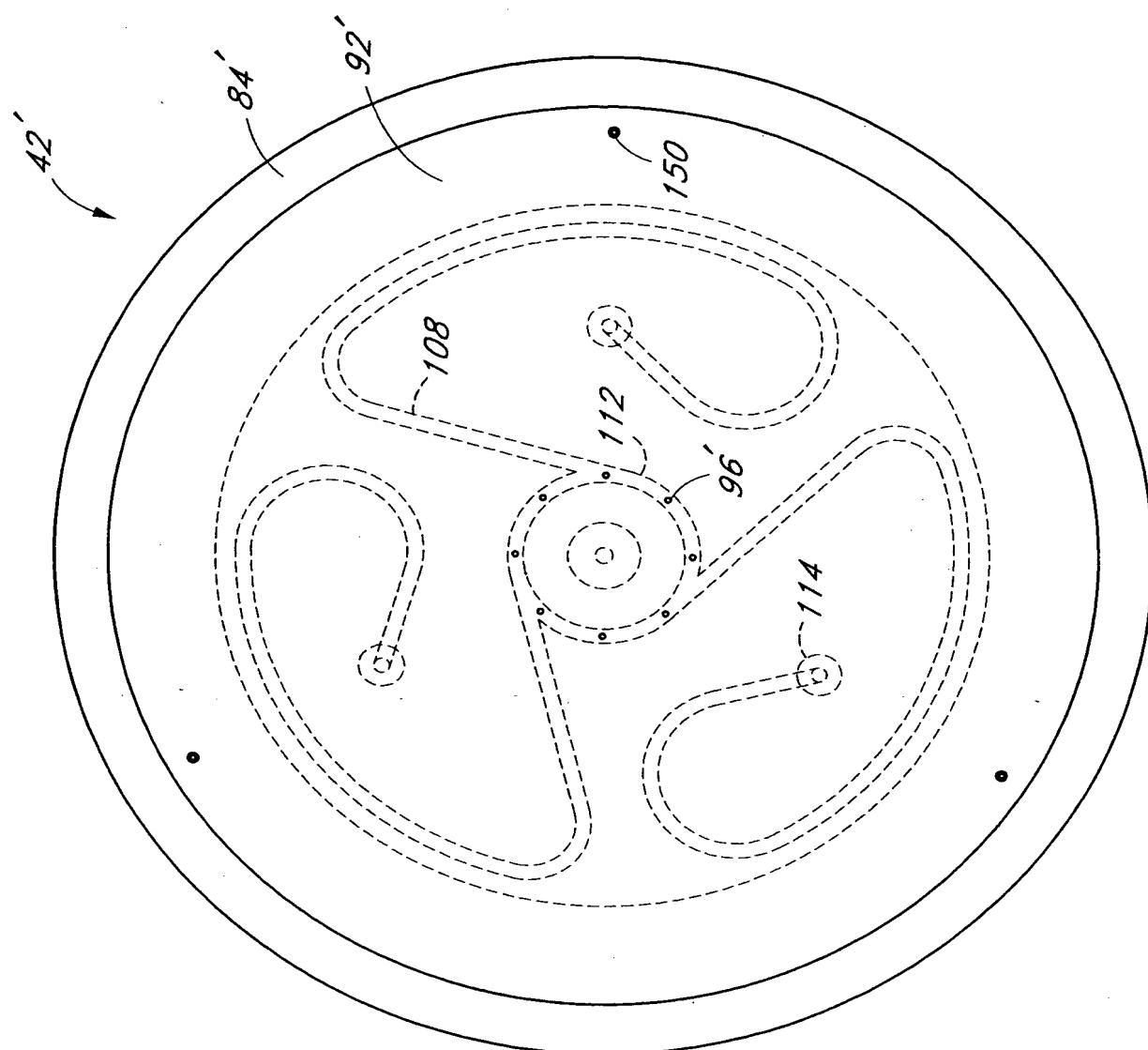


FIG. 8

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FIG. 9

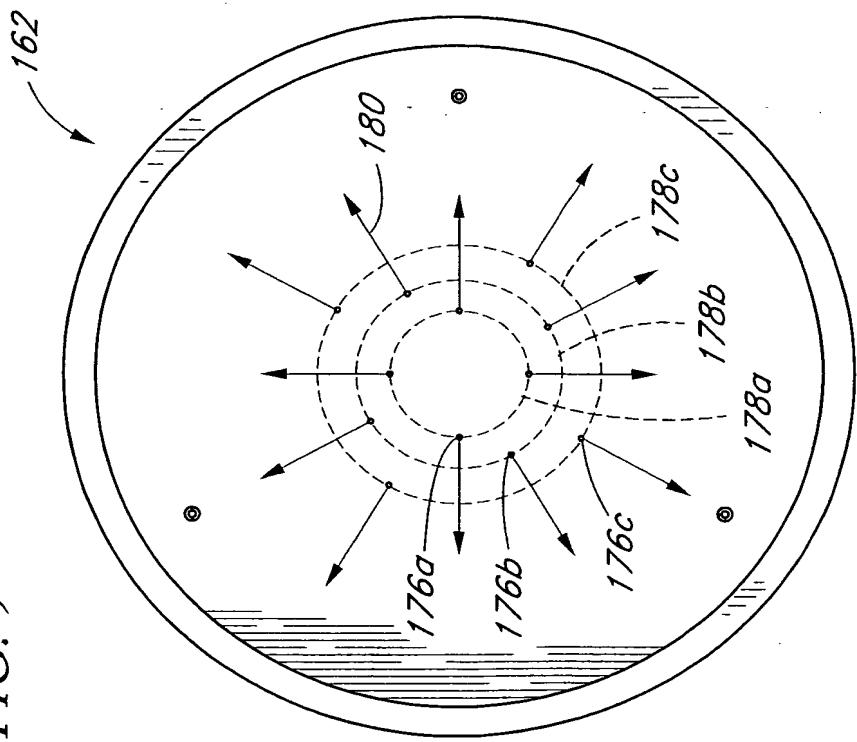
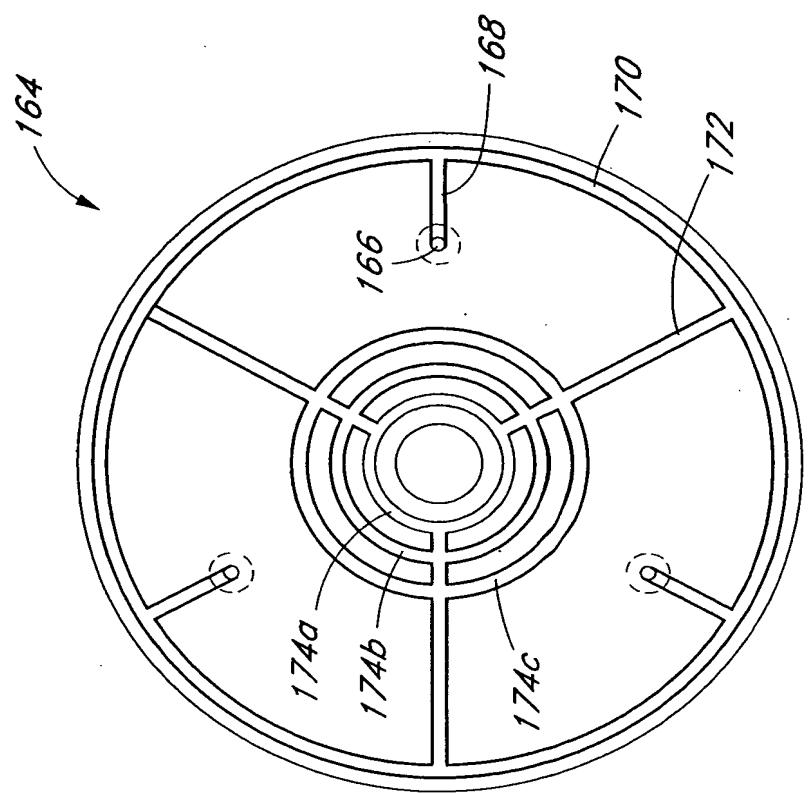
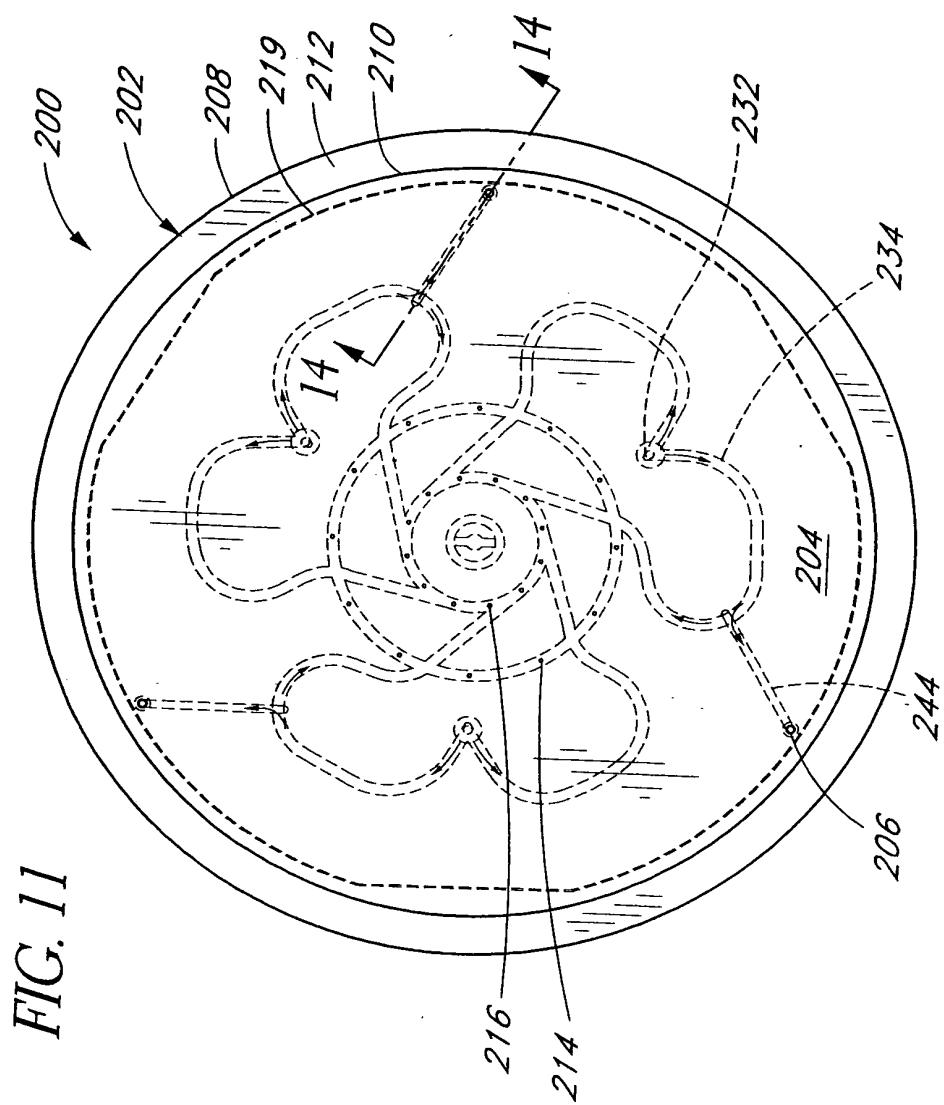
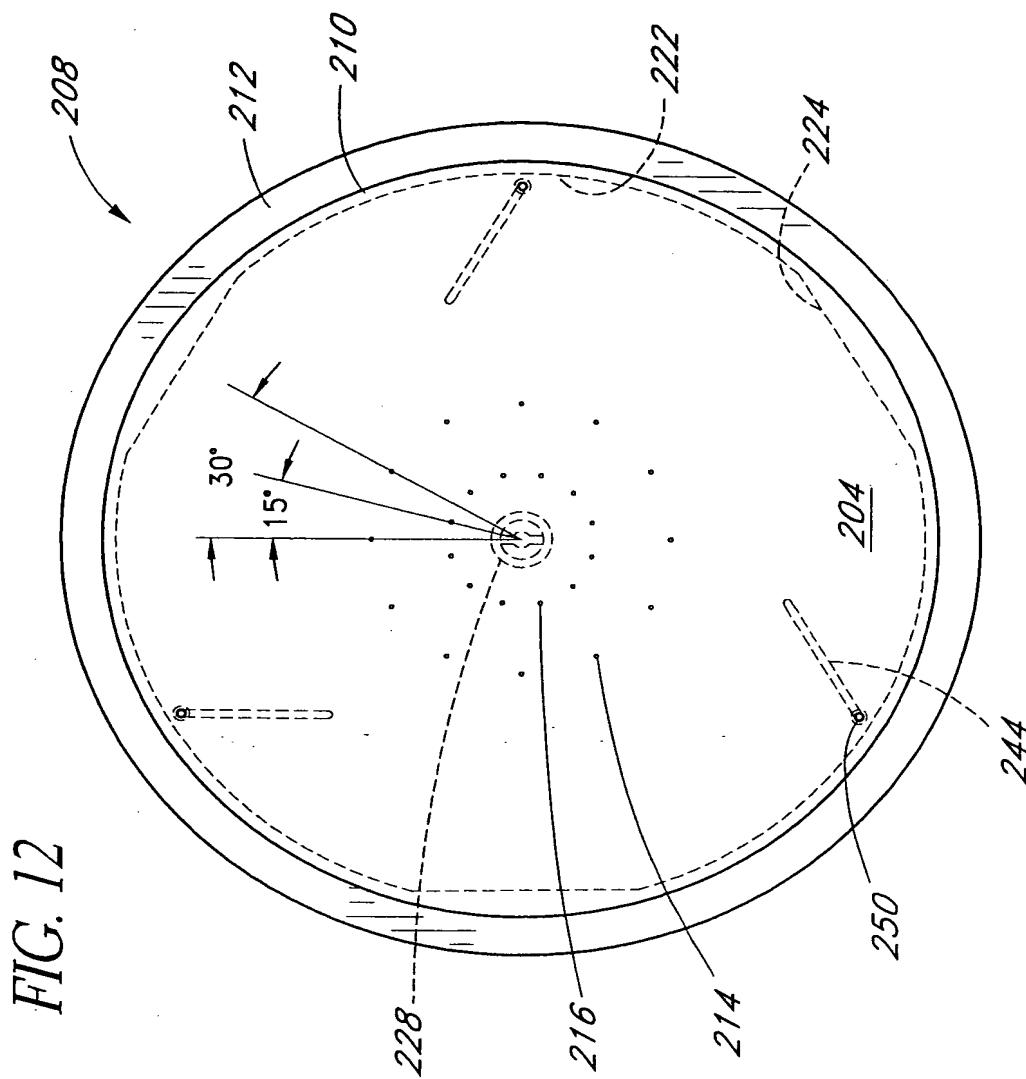
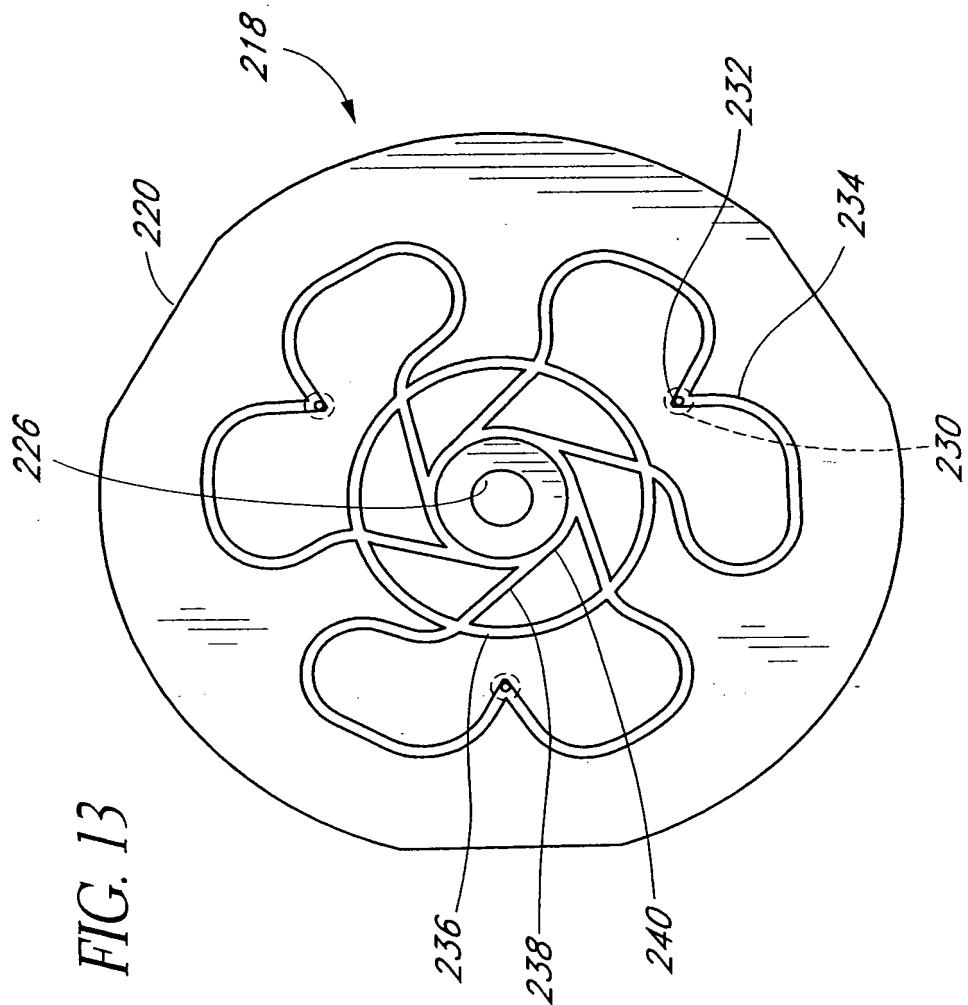


FIG. 10









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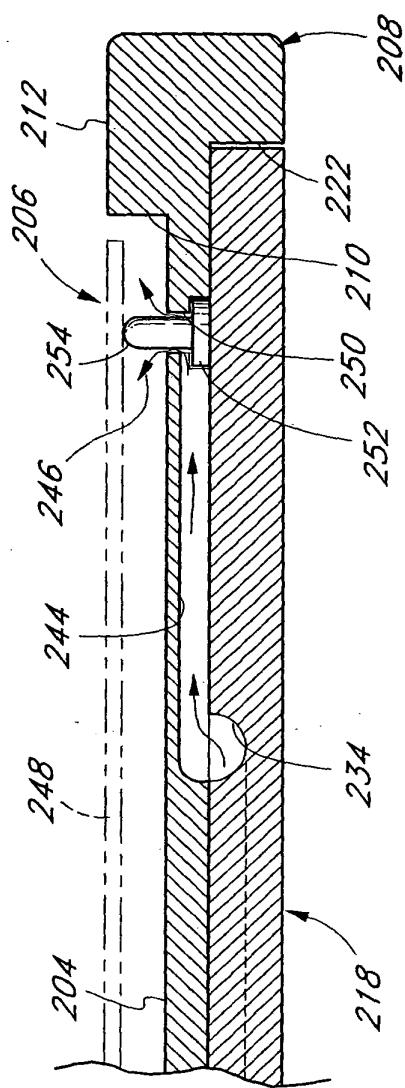


FIG. 14

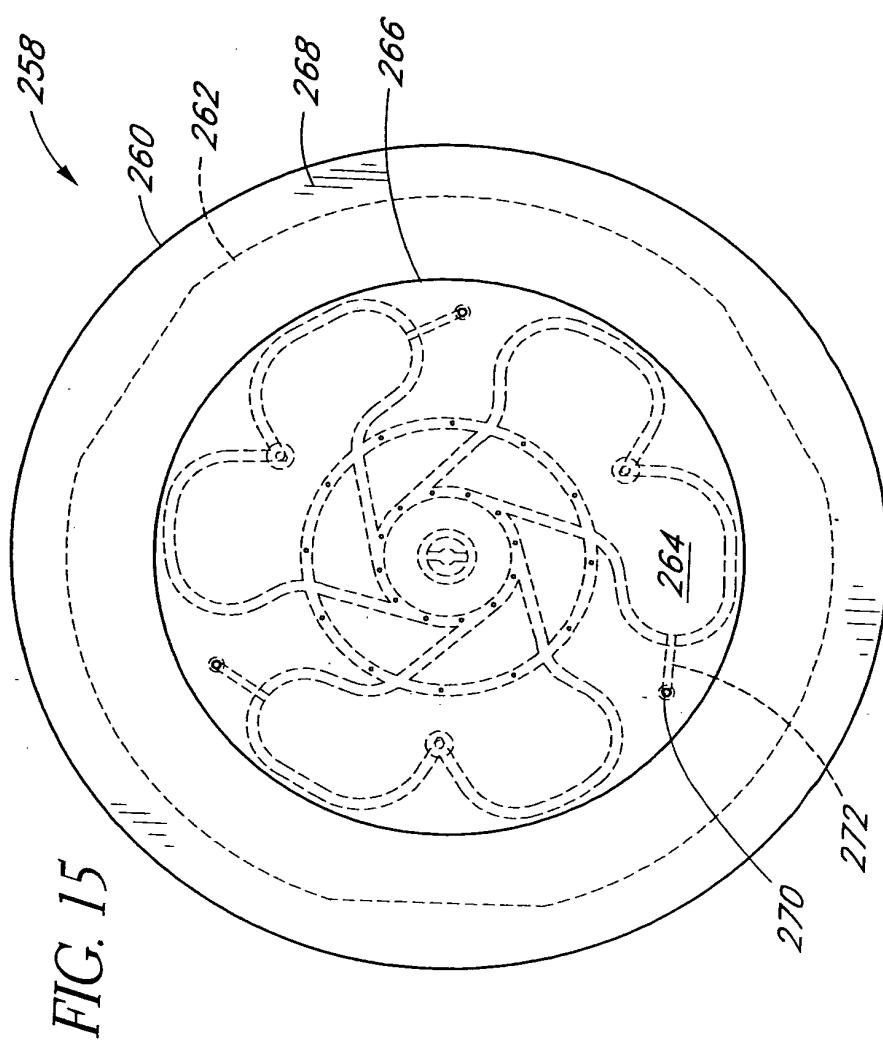
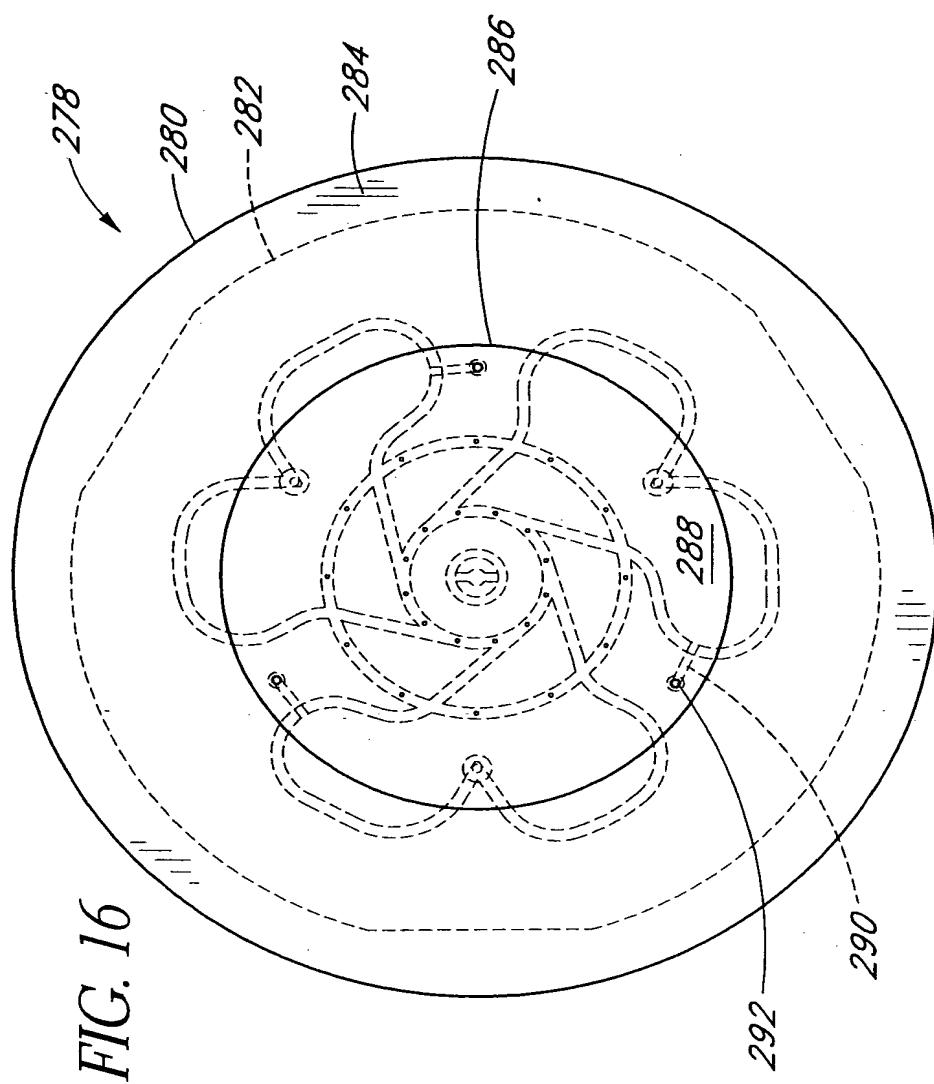
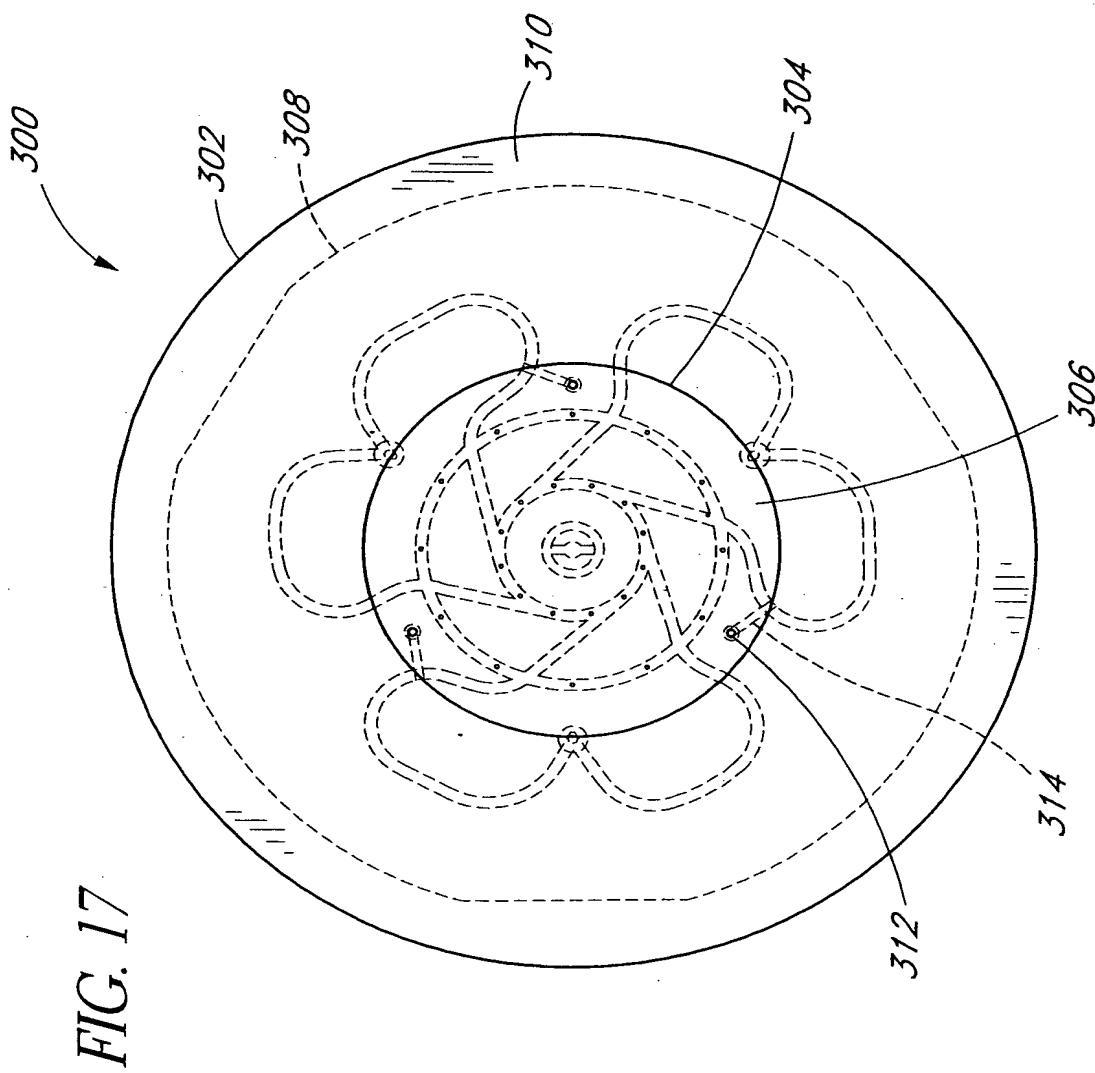
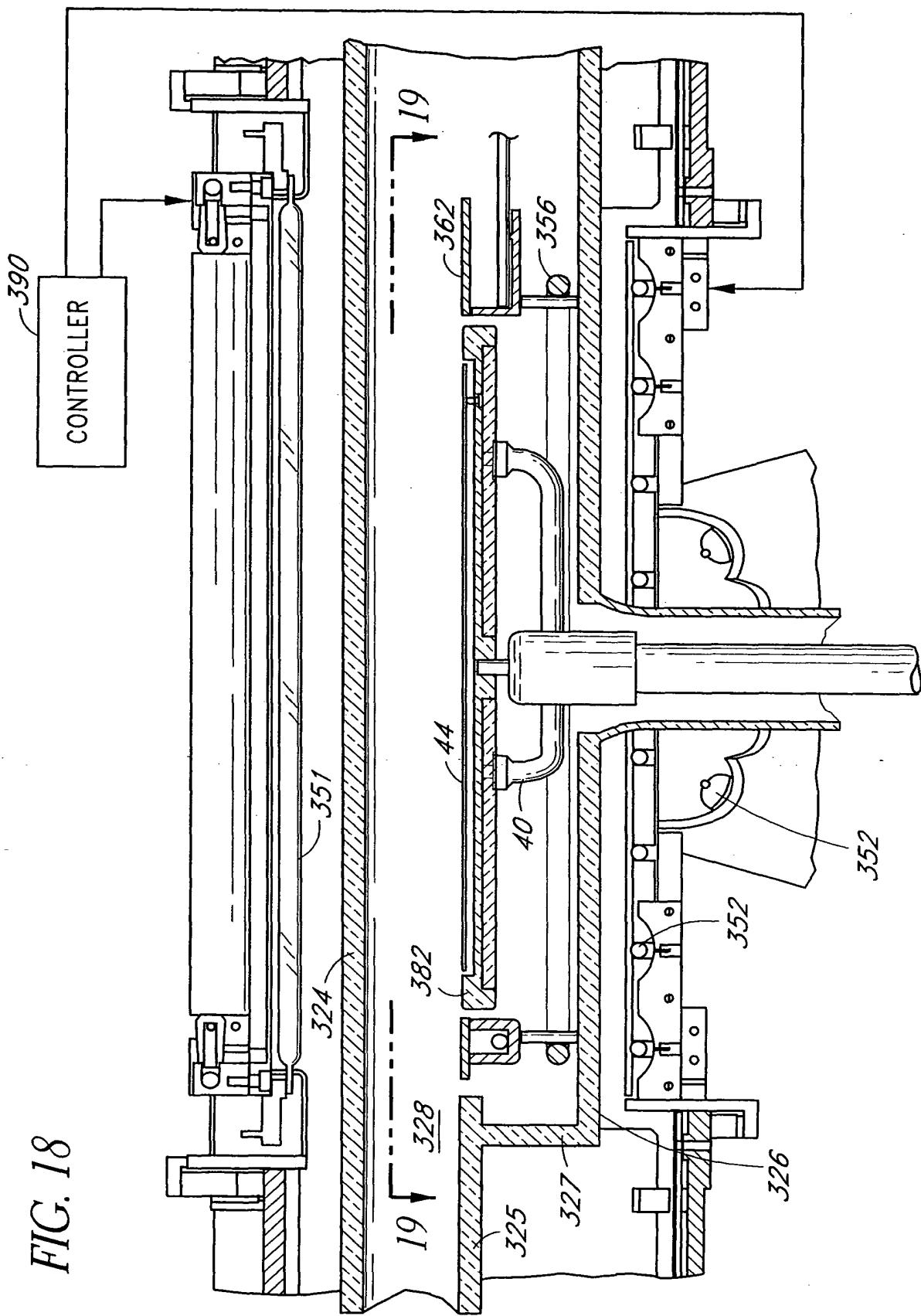


FIG. 15



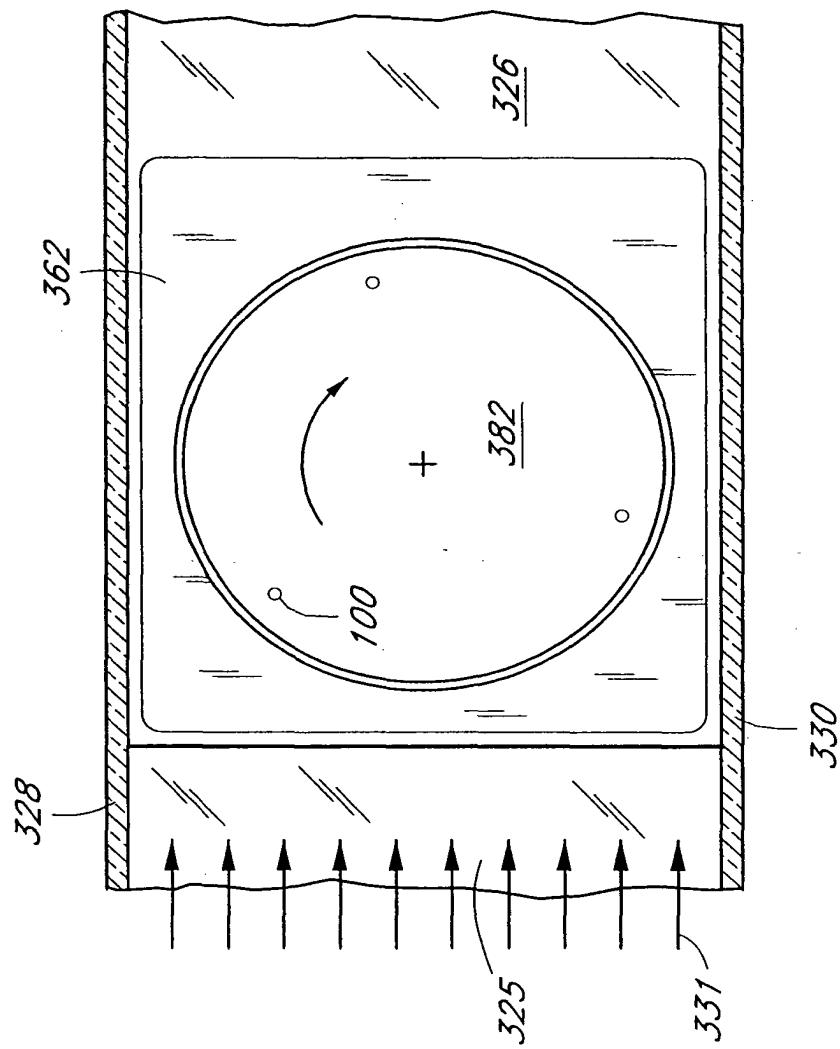
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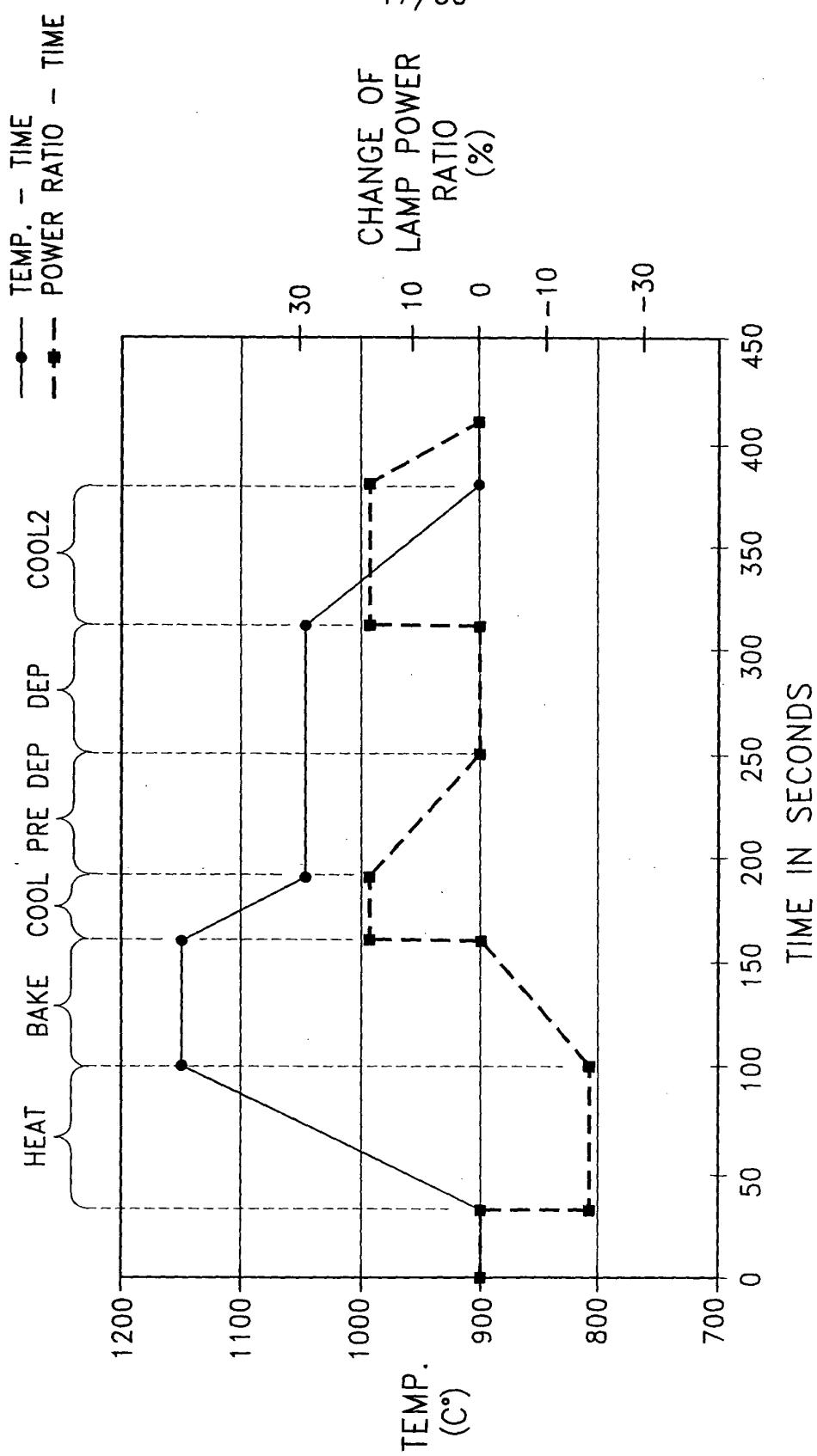
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FIG. 19



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FIG. 20



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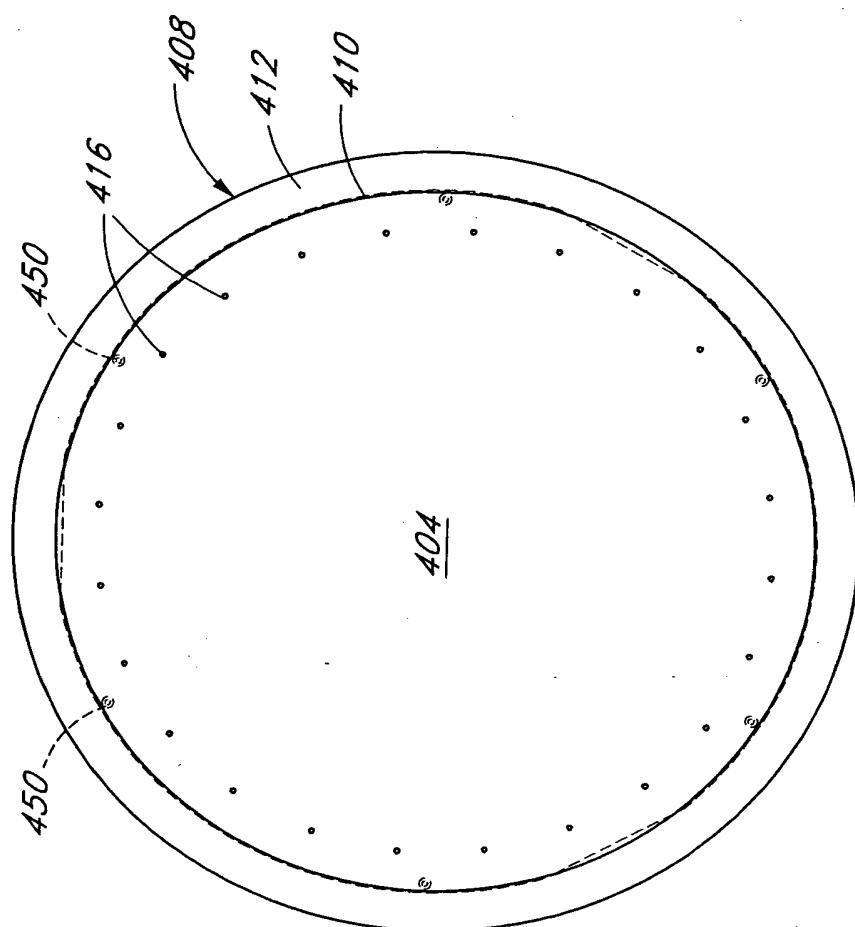


FIG. 21A

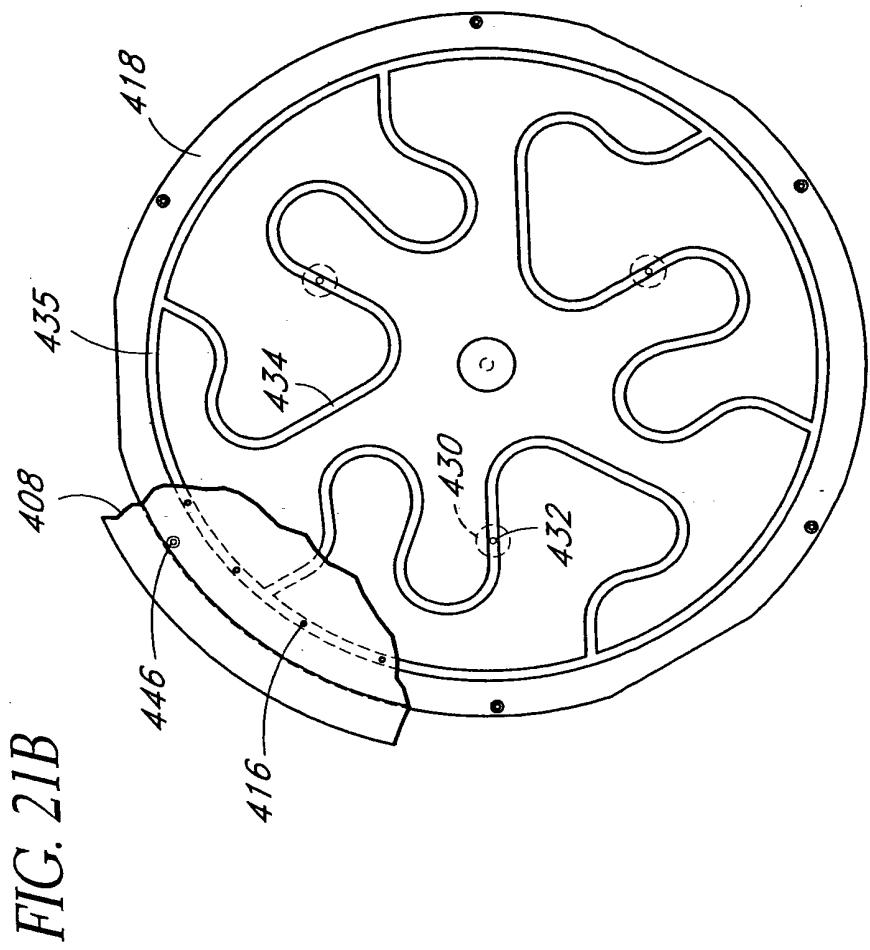
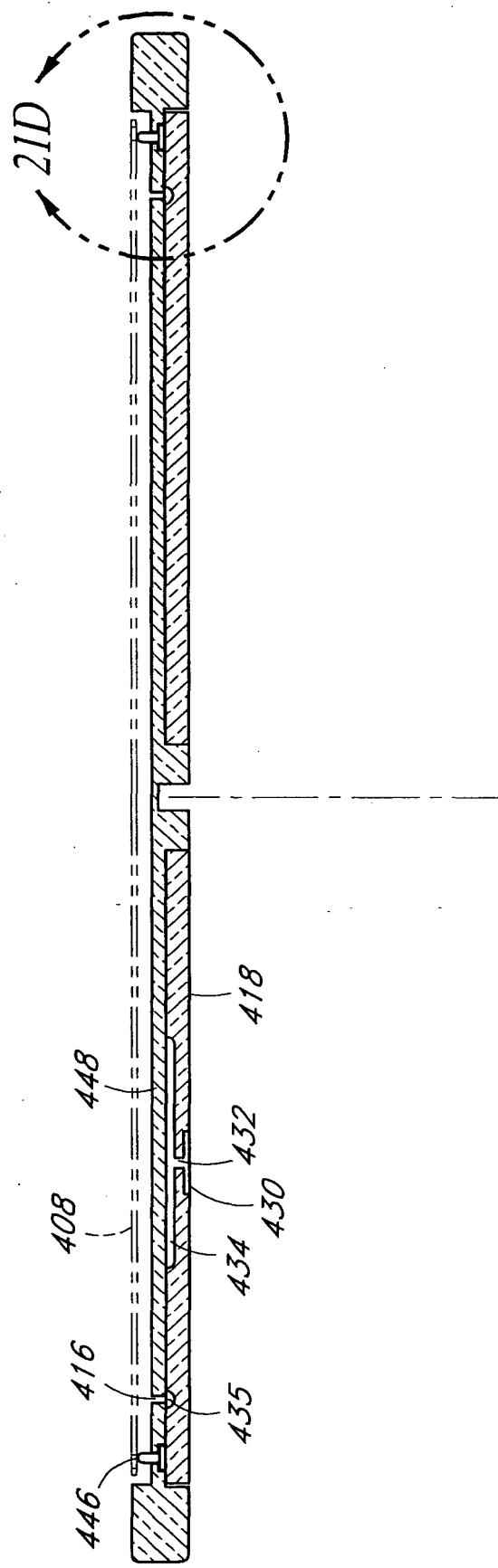


FIG. 21B

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FIG. 21C



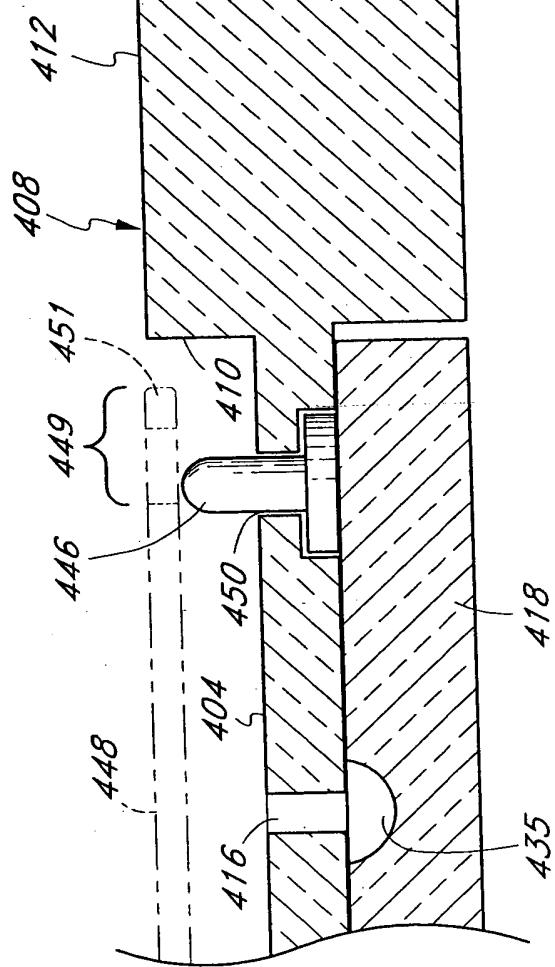


FIG. 21D

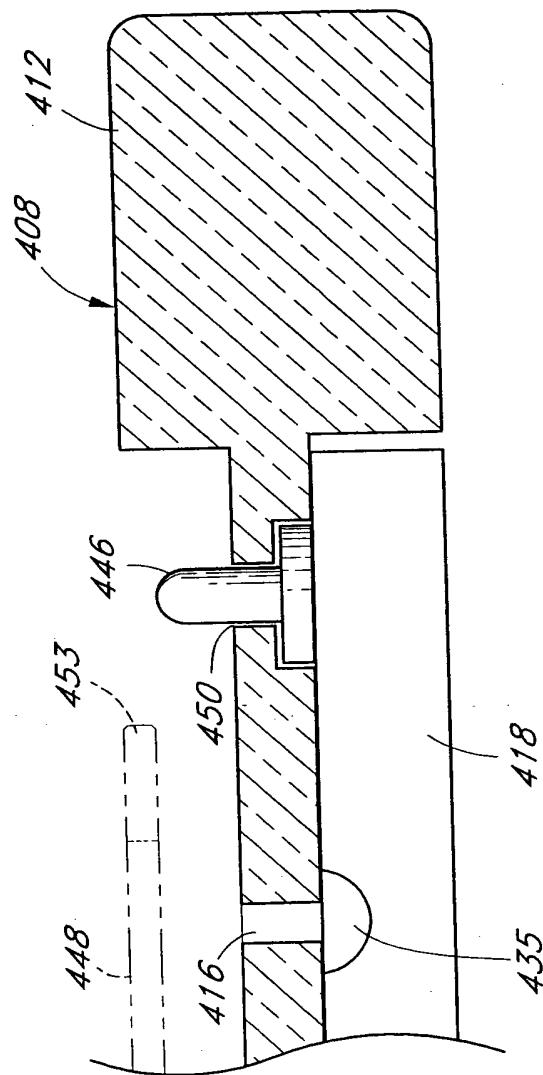
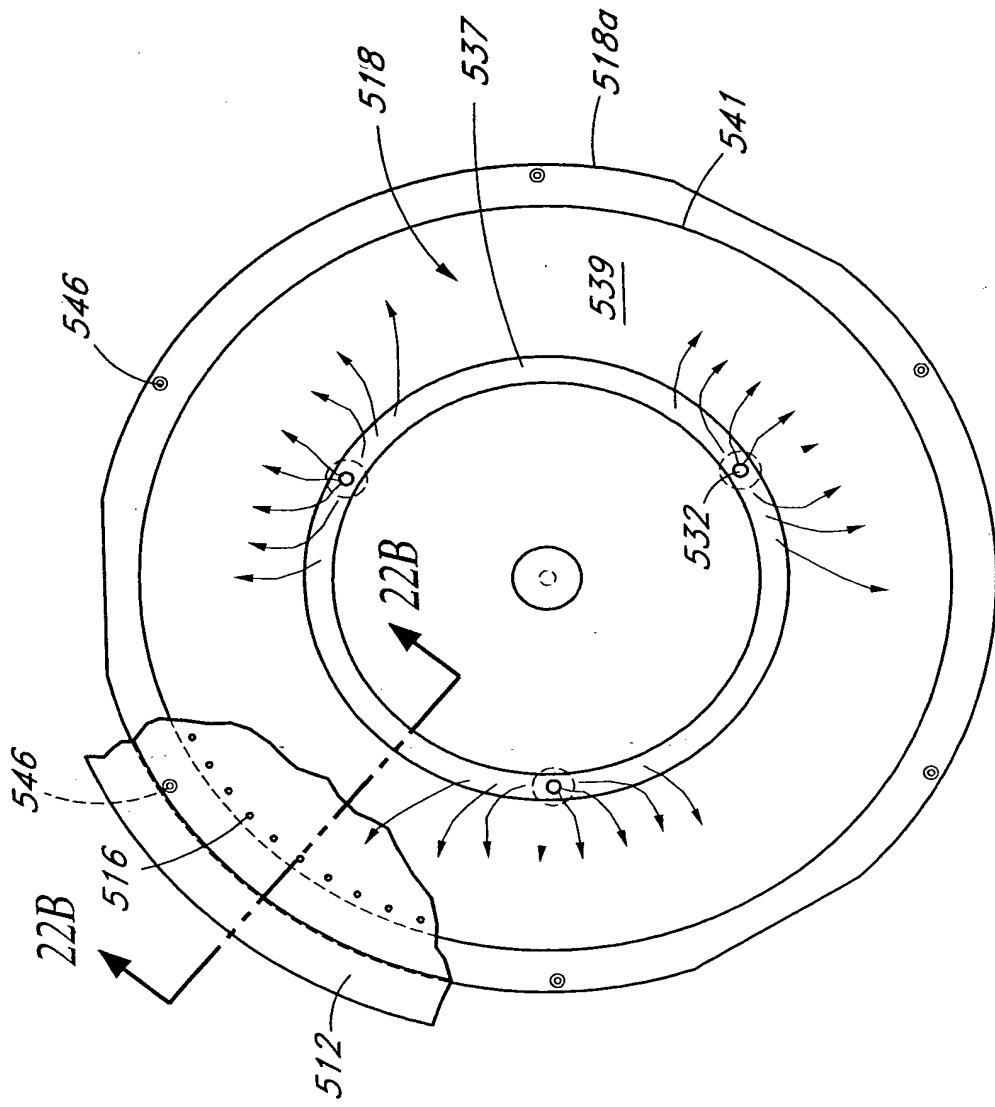


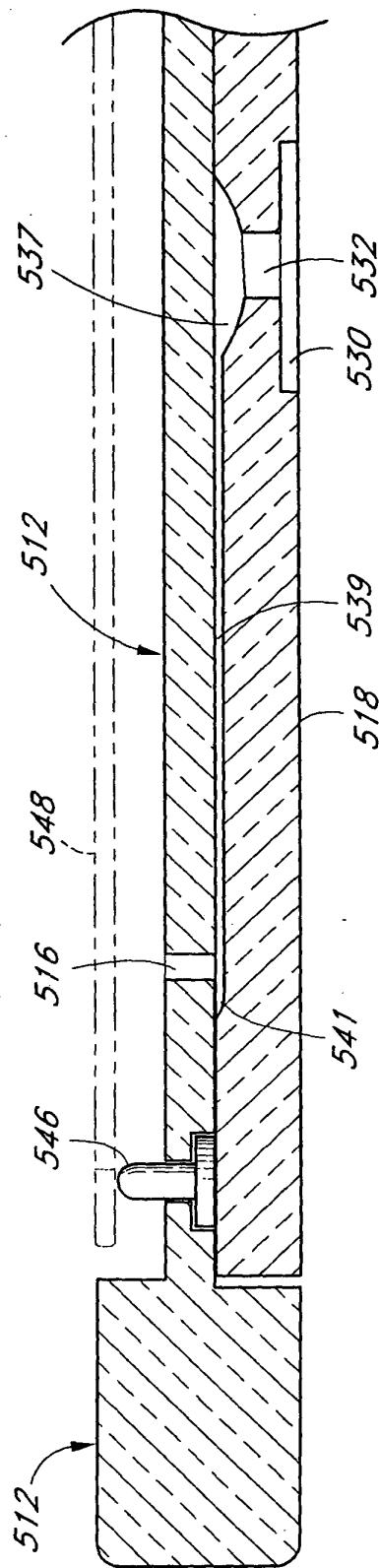
FIG. 21E

FIG. 22A

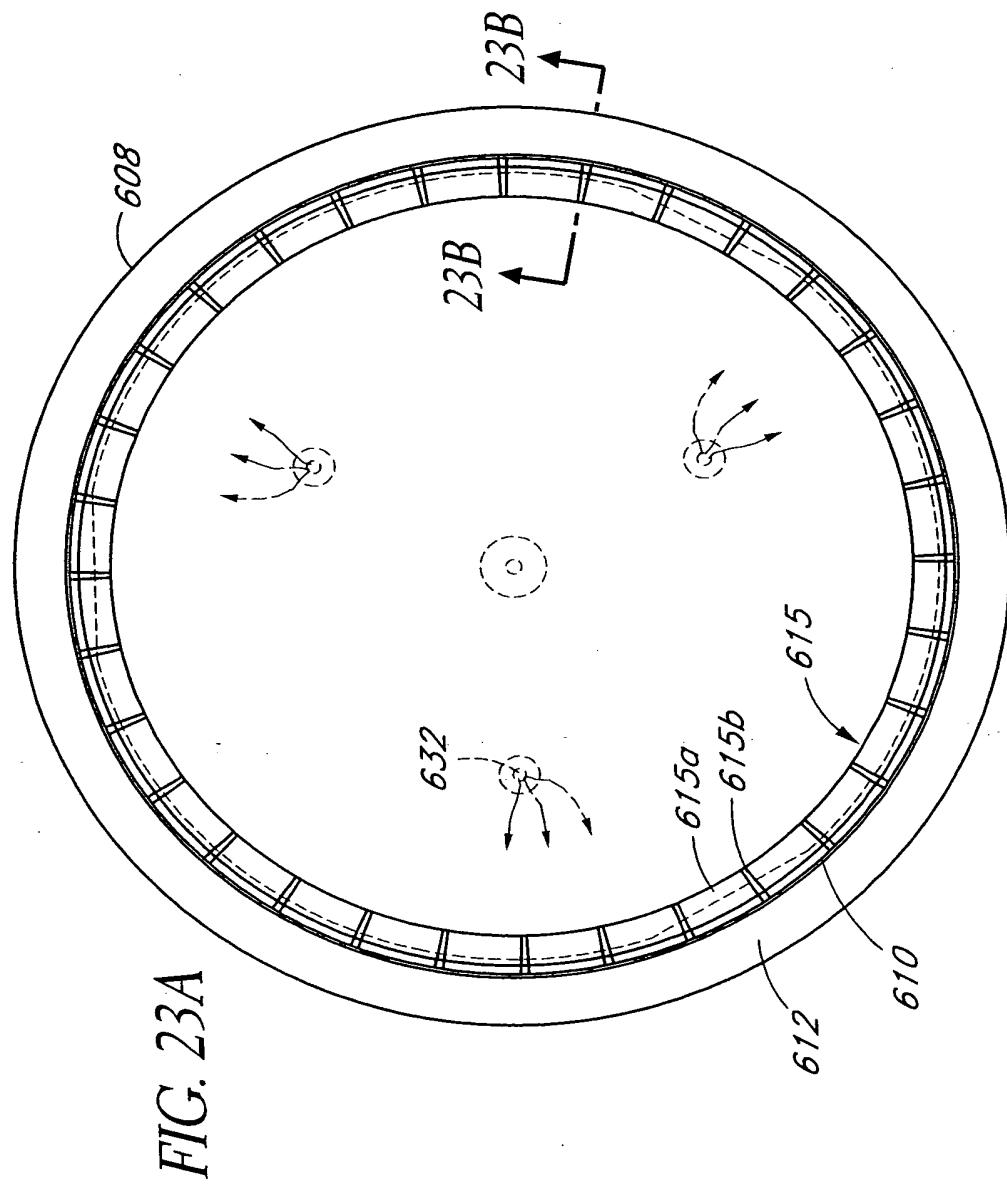


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FIG. 22B



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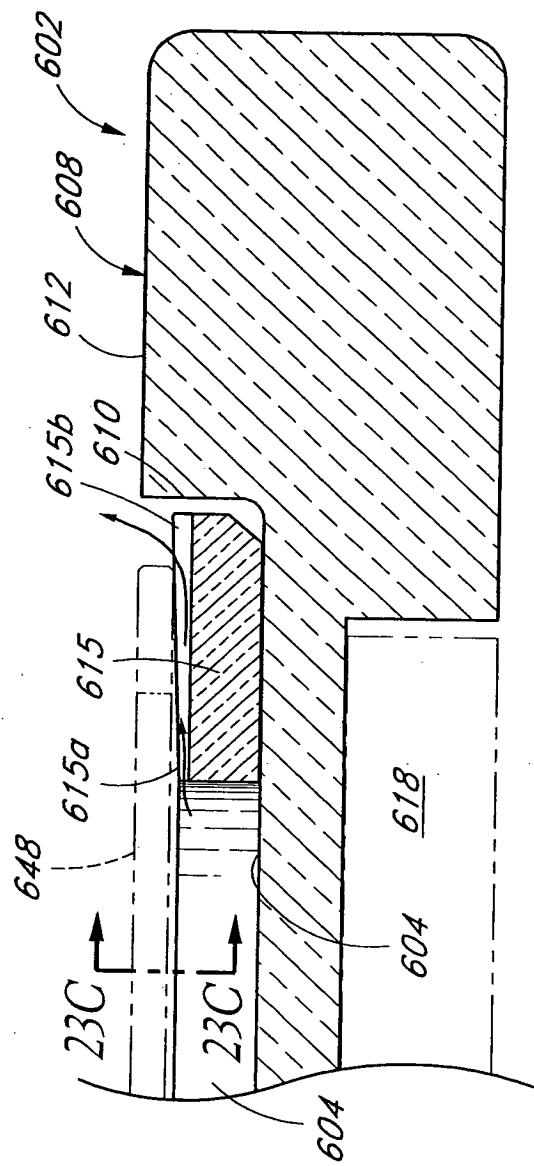


FIG. 23B

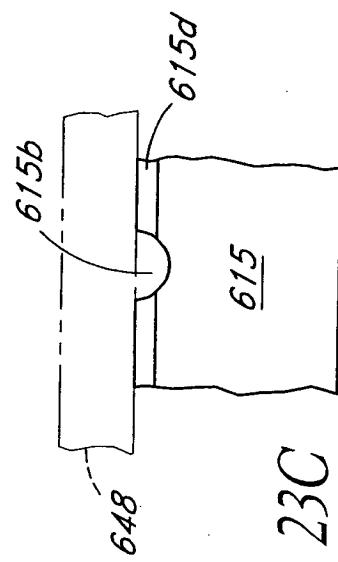


FIG. 23C

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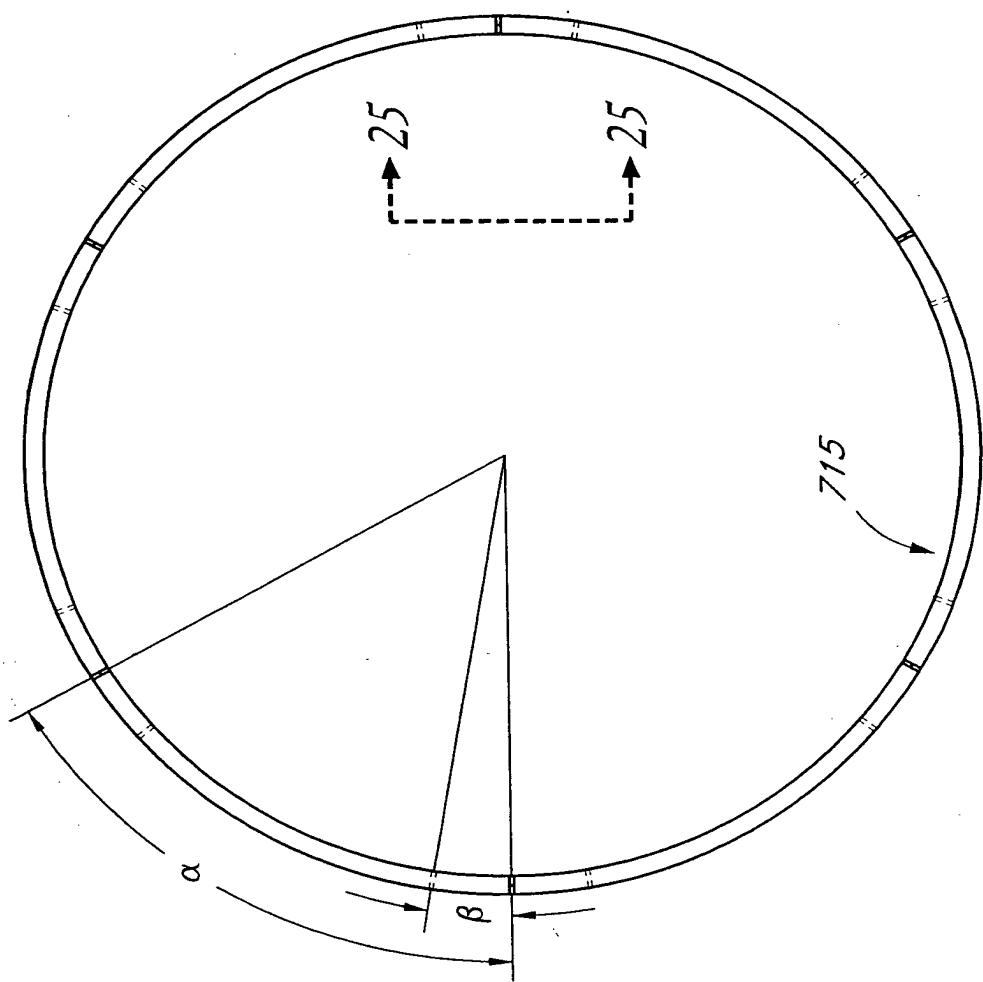
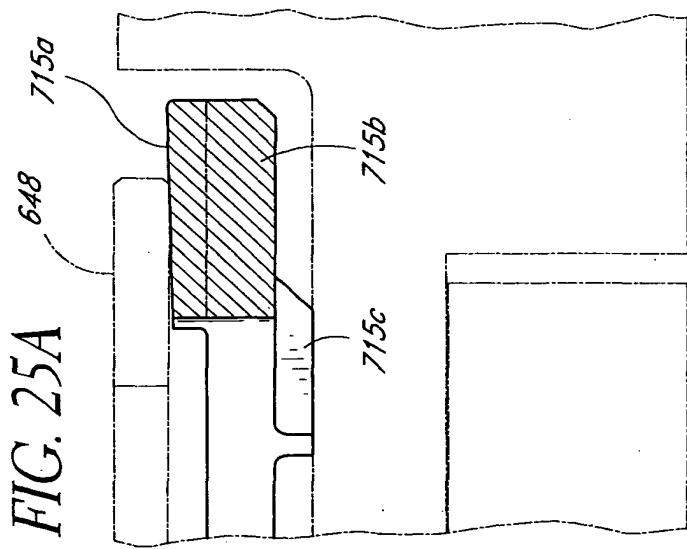
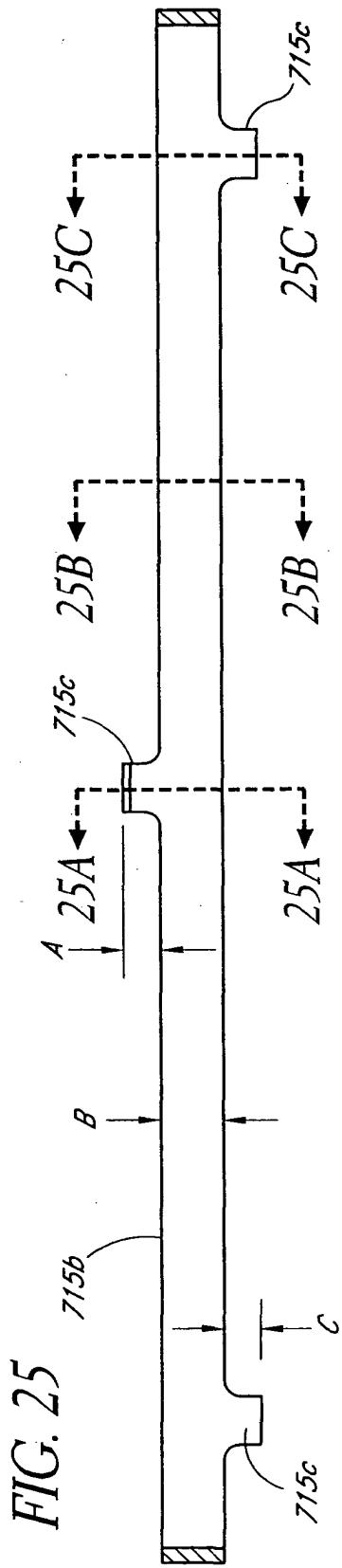
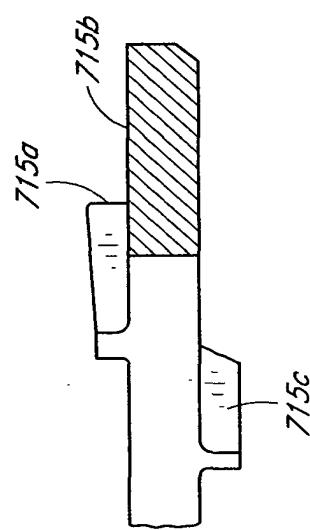
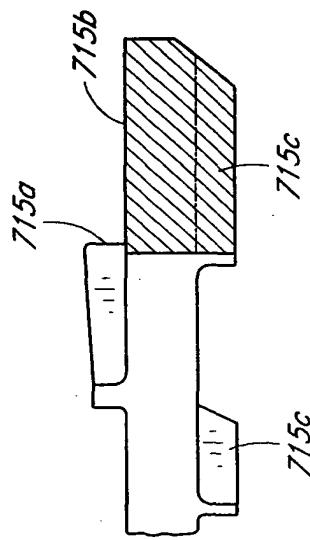


FIG. 24

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**FIG. 25C**

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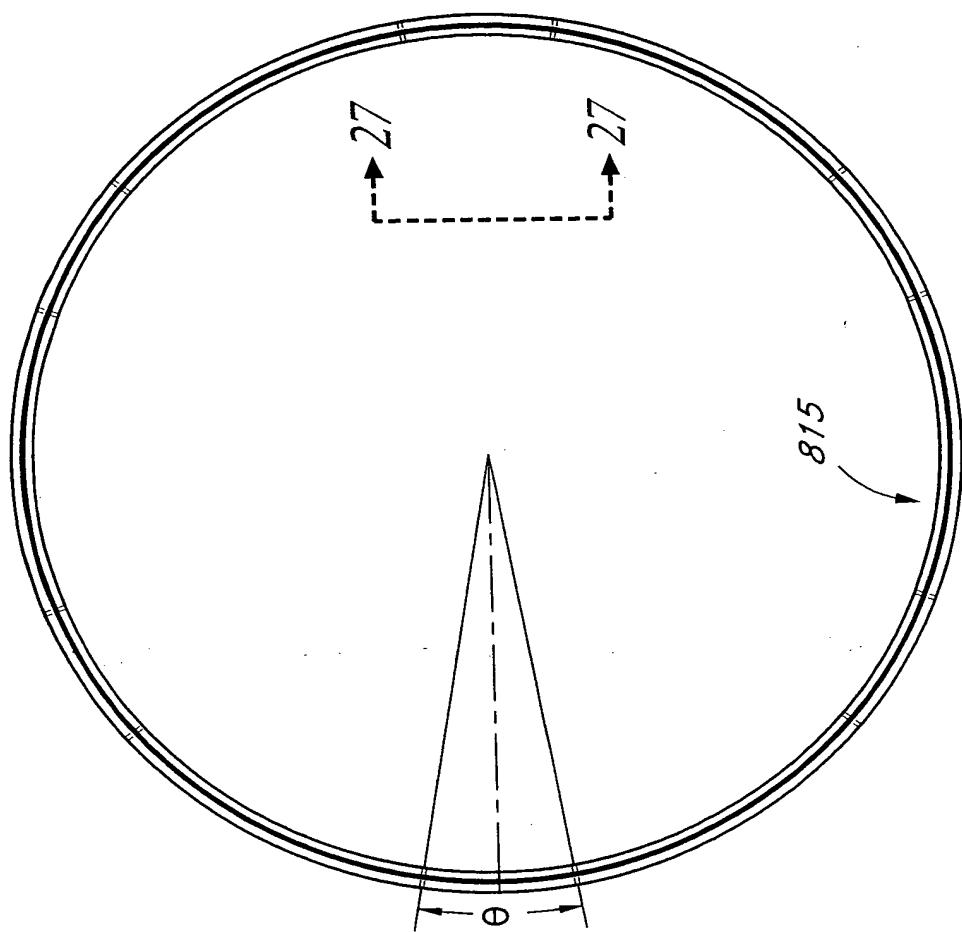
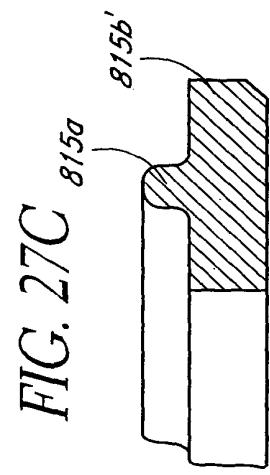
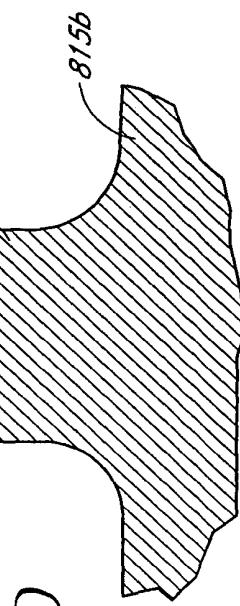
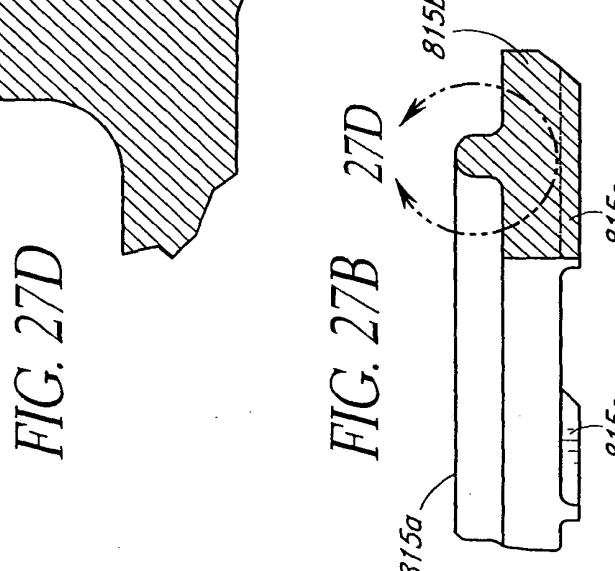
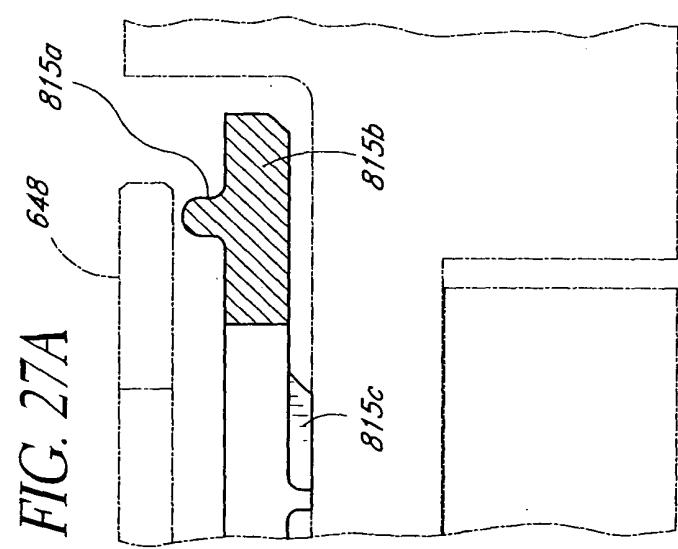
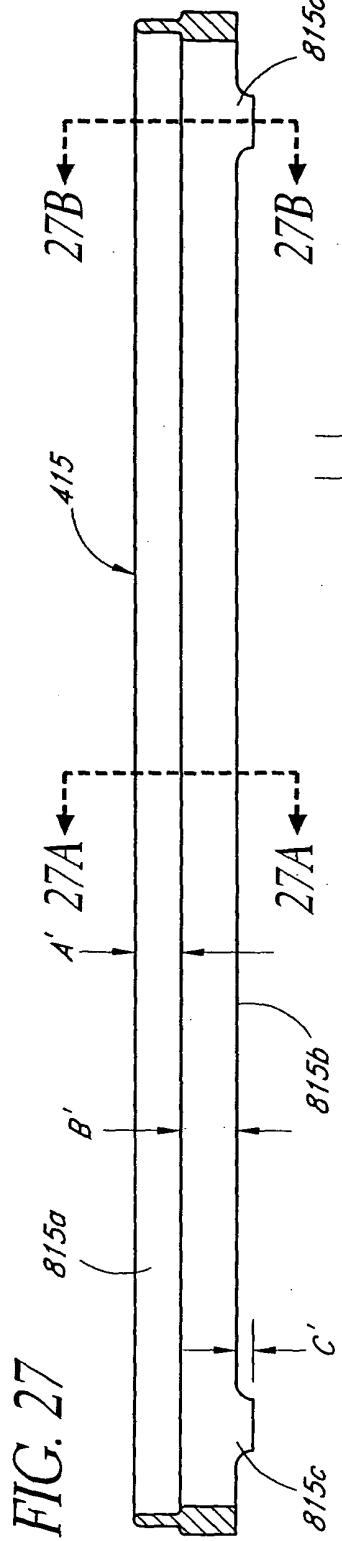


FIG. 26



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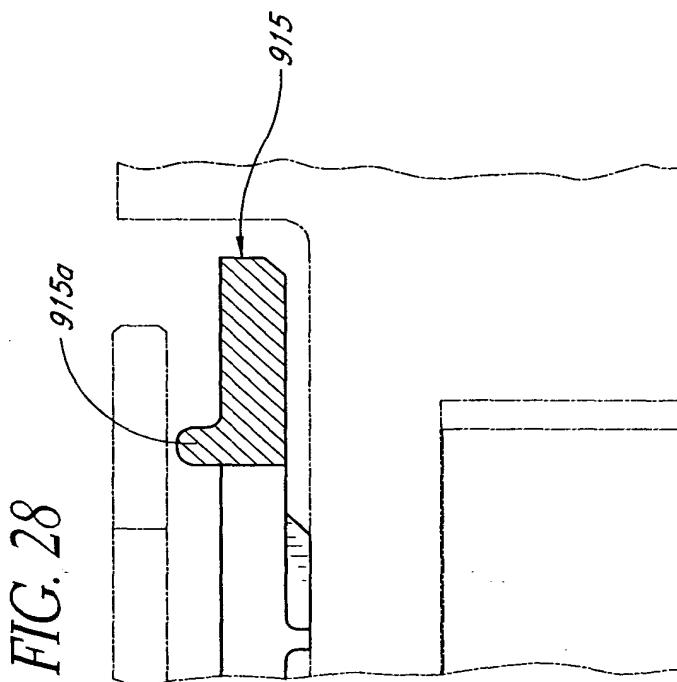


FIG. 28